

RECEIVED
CENTRAL FAX CENTER

DEC 19 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)	
Inventors: Joshi et al.)	
Serial No.: 10/812,591)	ATTORNEY FILE NO.
Filed: March 29, 2004)	SLA0786
Title: HIGH DENSITY PLASMA)	Customer No.: 55,286
PROCESS FOR THE FORM-)	Group Art: 2891
ATION OF SILICON DIOXIDE)	Examiner: Sarkar, Asok K.
ON SILICON CARBIDE)	
SUBSTRATES)	Confirmation No.: 2314

CERTIFICATION UNDER 37 CFR § 1.8

I hereby certify that this correspondence is being facsimile transmitted to the US Patent and Trademark Office, fax No. 571 273 8300, on this date 12/19/2005.

Date 12/19/2005 Signature 

MAIL STOP AMENDMENTS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

The present communication is responsive to a restriction requirement mailed November 29, 2005, for the above-mentioned application.

Attached is an Associate Power of Attorney.

SLA786_restrict

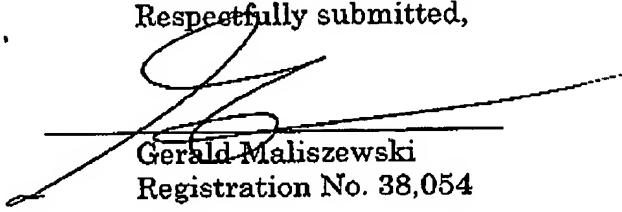
1

The Applicant elects to pursue Species I claims associated with
Flowchart 3.

The Applicant cancels claims 33-36 without traverse.

Respectfully submitted,

Date: 12/19/2005


Gerald Maliszewski
Registration No. 38,054

Customer Number 55,286
P.O. Box 270829
San Diego, CA 92198-2829
Telephone: (858) 451-9950
Facsimile: (858) 451-9869
gerry@ipatentit.net